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Bib Data Sheet

CONFIRMATION NO. 9134

SERIAL NUMBER 09/988,704	FILING DATE 11/20/2001 RULE	CLASS 382	GROUP ART UNIT 2621	ATTORNEY DOCKET NO. 2001_1718A	
APPLICANTS Shoriki Narita, Hirakata-shi, JAPAN; Masahiko Ikeya, Sakai-shi, JAPAN; Yasutaka Tsuboi, Hirakata-shi, JAPAN; Takaharu Mae, Hirakata-shi, JAPAN; Shinji Kanayama, Kashihara-shi, JAPAN;					
** CONTINUING DATA *****					
** FOREIGN APPLICATIONS ***** JAPAN 2000-354471 11/21/2000					
IF REQUIRED, FOREIGN FILING LICENSE GRANTED ** 12/03/2001					
Foreign Priority claimed <input type="checkbox"/> yes <input type="checkbox"/> no 35 USC 119 (a-d) conditions met <input type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance Verified and Acknowledged _____ Examiner's Signature Initials		STATE OR COUNTRY JAPAN	SHEETS DRAWING 18	TOTAL CLAIMS 15	INDEPENDENT CLAIMS 2
ADDRESS 000513					
TITLE Method and apparatus for correcting inclination of IC on semiconductor wafer					
FILING FEE RECEIVED 870	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:		<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit		